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CONFIRMATION NO. 6245

SERIAL NUMBER 10/650,193	FILING OR 371(c) DATE 08/28/2003 RULE	CLASS 257	GROUP ART UNIT 2826	ATTORNEY DOCKET NO. Q77191
APPLICANTS Koichi Ohto, Kanagawa, JAPAN; Toshiyuki Takewaki, Kanagawa, JAPAN; Tatsuya Usami, Kanagawa, JAPAN; Nobuyki Yamanishi, Kanagawa, JAPAN;				
** CONTINUING DATA ***** This application is a CIP of 10/281,321 10/28/2002 ABN				
** FOREIGN APPLICATIONS ***** JAPAN 2002-132780 05/08/2002 JAPAN 2002-302841 10/17/2002 JAPAN 2003-130484 05/05/2003				
IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 11/28/2003				
Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after met <u>Allowance</u> Verified and <u>Examiner's Signature</u> Acknowledged <u>Initials</u>		STATE OR COUNTRY JAPAN	SHEETS DRAWING 87	TOTAL CLAIMS 212
INDEPENDENT CLAIMS 17				
ADDRESS 23373				
TITLE Semiconductor device having silicon-diffused metal wiring layer and its manufacturing method				
FILING FEE RECEIVED 6232	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit	